

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	187	chuck same coating\$1 same reflect\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/27 09:44
S2	12	S1 same electrostatic	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 11:22
S3	187	chuck same coating\$1 same reflect\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 11:23
S4	2	S3 same alumina	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 11:32
S5	0	S3 same leaky	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 11:24
S6	15	S3 same protect\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 11:24
S7	17	S3 same metal same layer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 11:32
S8	675	(361/234).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/04/25 11:37
S9	100	S8 and reflect\$3	US-PGPUB; USPAT	OR	ON	2006/04/25 11:45

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S10	63	S9 and coat\$3	US-PGPUB; USPAT	OR	ON	2006/04/26 09:45
S11	43	S10 and chuck	US-PGPUB; USPAT	OR	ON	2006/04/25 11:39
S12	1	S8 and (reflective adj coating) and chuck	US-PGPUB; USPAT	OR	ON	2006/04/25 11:45
S13	60	chuck same coating\$1 same reflective	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 13:22
S14	18055	(chuck wafer) same (coating\$1 layer surface) same CVD	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/27 10:06
S15	3	S14 same electrostatic same reflective	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 13:25
S16	340	S14 same electrostatic	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 13:29
S17	105	S16 same (aluminum metal alumina IR infra-red)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 13:30
S18	1	S17 same reflective	US-PGPUB; USPAT	OR	ON	2006/04/25 15:16
S19	2	"200031774"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 15:49
S20	3798	(reflective corrosion-resistant) same (coating layer surface) same (infra-red IR)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:06

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S21	886	S20 same (glass ceramics)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 15:51
S22	1029	S20 same (glass ceramics dielectric)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:07
S23	426	S22 same (aluminum metal)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:07
S24	16	S23 same (alumina)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:08
S25	8516	(reflective corrosion-resistant) same (coating layer surface) same (infrared IR)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:06
S26	2280	S25 same (glass ceramics dielectric)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:07
S27	1011	S26 same (aluminum metal)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:07
S28	37	S27 same (alumina)	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:08
S29	22	S28 not S24	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 16:09
S30	1	("6916559").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/04/26 09:46
S31	0	(alumina-coated adj glass) same chuck same wafer	E.O.; IPO	OR	ON	2006/04/27 09:46
S32	0	(alumina-coated adj glass)	E.O.; IPO	OR	ON	2006/04/27 09:46
S33	0	alumina same glass same chuck same wafer	E.O.; IPO	OR	ON	2006/04/27 09:47
S34	1	JP08275566	E.O.; IPO; E.O. ENT	OR	ON	2006/04/27 09:53
S35	305217	(chuck wafer) same (coating\$1 layer surface)	US-PGPUB; USPAT; USOCR; E.O.; IPO; E.O. ENT; I.O. BOB	OR	ON	2006/04/27 10:07

EAST Search ory

S36	3414	S35 same (relective refractive ptotect\$3)	PGFJB; L T; L IS; E PO; F ENT; I B	OR	ON	2006/04/27 10:08
S37	30	S36 same electrostatic	L JB; L A; L CR; E PO; F ENT; B	OR	ON	2006/04/27 10:08
S38	17	S37 same (alumina aluminum metal glass ceramics dielectric)	L JB; L T; L IS; E PO; F ENT; B	OR	ON	2006/04/27 10:09

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